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Application Number	10/817,089
Filing Date	April 2, 2004
First Named Inventor	Getty et al.
Group Art Unit	Unknown
Examiner Name	Unknown
Attorney Docket Number	CL2127 US NA

Sheet	1	of	3
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4126/05

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				Filing Date	April 2, 2004
				First Named Inventor	Getty et al.
				Group Art Unit	Unknown
				Examiner Name	Unknown
Sheet	2	of	3	Attorney Docket Number	CL2127 US NA

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Examiner Initials *	Cite No. <sup>1</sup>	Include name of the author (in CAPITAL LETTERS), title of the article (when appropriate), title of the item (book, magazine, journal, serial, symposium, catalog, etc.), date, page(s), volume-issue number(s), publisher, city and/or country where published.	T <sup>2</sup>
HADN	—	J. Lu et al., Kelvin Probe Force Microscopy on Surfaces: Investigation of the Surface Potential of Self-Assembled Monolayers on Gold, Langmuir, Vol. 15, pp. 8184, 1999	—
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Examiner Signature	Huei-An D. Nguyen	Date Considered	4/26/05
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